Development of a combined machining method using electrorheological fluids for EDM

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A R T I C L E   I N F O

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A B S T R A C T

The objective of this study is to develop a new combined technology of electrical discharge machining (EDM) with polishing by using electrorheological (ER) fluid as working fluid. The surface of the work-piece after EDM has a recast layer with many micro-craters and cracks. Therefore, the polishing process is usually required after EDM for the molds applied on computer, communication and consumer electronics (3C) industries. In the study, we proposed a novel method of EDM that used ER fluid instead of water or oil and employed fine abrasive grits to carry out the combined process of EDM and polishing. The effect of this new electromechanical process combining EDM and polishing was investigated. The experimental results demonstrate EDM process still can perform in the ER fluid and polishing process can be surely performed after adding the alumina abrasives. We have a good performance to obtain surface roughness of $R_a 0.08–0.06\mu m$ when using alumina abrasives of $0.3\mu m$ and discharge capacity of $0.01\mu F$ in the proposed method.

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1. Introduction

The requirements of molds and dies for 3C industry are not only the smaller size but also the higher precision and the finer surface roughness. Electrical discharge machining (EDM) process has excellent performance on machining of hard material, which is an important method for mold industry. However, the surface after EDM has recast layer with many craters and micro-cracks. Polishing is a post-process after EDM and usually essential to obtain mirror-like surface. Except for cost of time and money, polishing process is also difficult to perform specially for small size of mold.

In this study, we proposed a novel method of EDM that used electrorheological (ER) fluid instead of water or oil and employed abrasive to carry out polishing process as shown in Fig. 1. Since there is very strong electric field between work-piece and electrode before discharge occurrence, it is possible to induce the electric field to assist polishing in EDM. For interval time of discharge pulse, ER particles will become fibrous chains as the result of polarization. And then the fibrous chains seem to be working as polishing brushes dragging abrasive to carry out polishing process. This new developed method will combine EDM and polishing in one process. It would save time and make the economical efficiency much better.

The electrorheological fluid was also called Winslow fluid which was discovered by Winslow (1949). It consisted of dielectric particles in the insulating fluid. These dielectric particles are polarized easily under high electric field strength and then the ER fluid will transform into a plastic flow. If the electric field were stronger, even the ER fluid will be solidified (Vinogradov et al., 1986). The viscosity of the ER fluid is varied due to the electric field. It is a Newtonian fluid without the electric field applied but it becomes the Bingham plastic flow when applying the electric field (Bonneceze and Brady, 1992). Fig. 2 shows the mechanism for the electrorheological behavior.

Kuriyagawa et al. (2002) firstly utilized ER fluid for the polishing of optical micro-lenses. They used the rotary metal tool...
Fig. 1 – Schematic diagram of the proposed method using ER fluid and abrasive gifts.

Fig. 2 – Schematic diagram of the mechanism for the electrorheological behavior: (a) without electric field and (b) with strong electric field.

and plate covering the lens to build the electric field. The space of electric field was full of the abrasive and the ER fluid. The abrasives are held softly at the tip of the tool to polish the small parts.

Kim et al. (2003) discussed the dipolar interaction force and the translational force along the electric field on the ER particles to understand the process of ER fluid-assisted polishing.

2. Experimental

2.1. Experimental procedure

This novel method is a new try-out and the performance of EDM in ER fluid with suspending starch powder in silicone oil was examined firstly. The influences of starch concentration on pulse waveform and discharge frequency were discussed. Then, adding Al₂O₃ abrasive in ER fluid induces polishing process to EDM in ER fluid. The effect of this new electromechanical process combining EDM and polishing was investigated. We especially tried to discuss the surface roughness in this combined machining process.

2.2. Experimental apparatus

The abrasive was Al₂O₃ with the diameters of 17.6 μm, 1 μm, and 0.3 μm. The working fluid was composed of different con-

<table>
<thead>
<tr>
<th>Table 1 – Experimental parameters</th>
<th>Working condition</th>
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<tbody>
<tr>
<td>Working factor</td>
<td>Working condition</td>
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<tr>
<td>Electrode</td>
<td>Copper</td>
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<tr>
<td>Work-piece</td>
<td>Stainless steel (SUS304)</td>
</tr>
<tr>
<td>Abrasive</td>
<td>Alumina powder (Al₂O₃)</td>
</tr>
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<td>Working fluid</td>
<td>Conventional EDM oil, ER fluid with different cons.</td>
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<tr>
<td>ER particle</td>
<td>Starch</td>
</tr>
<tr>
<td>Particle size (μm)</td>
<td>17.6 (~ 325 mesh), 1, 0.3</td>
</tr>
<tr>
<td>Concentration of abrasive (%)</td>
<td>0, 5, 10, 20, 30</td>
</tr>
<tr>
<td>Concentration of starch (%)</td>
<td>0, 10, 20, 30, 40, 60</td>
</tr>
<tr>
<td>Discharge voltage (V)</td>
<td>100, 250</td>
</tr>
<tr>
<td>Capacitance (μF)</td>
<td>0.068, 0.01</td>
</tr>
<tr>
<td>Rotational speed (rpm)</td>
<td>2000</td>
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Fig. 3 – Discharge spark when EDM in ER fluid.
concentrations of Al₂O₃ powders and starch. The gap between electrode and work-piece was kept below 50 μm. The copper was used as the cathode which was 1 mm in diameter with rotational speed of 2000 rpm, and stainless steel was used as work-piece in all experiments. The discharge voltage of 100 V and 250 V are used. The discharge capacitance had 0.068 F and 0.01 F. The parameters used in the experiments were listed in Table 1.

3. Experimental results and discussion

3.1. Performance of EDM in ER fluid

3.1.1. Examination of discharging waveform

It was easy to find the occurrence of discharge spark during the process of EDM in ER fluid as shown in Fig. 3, which seems
to be the same as general EDM in oil. An oscilloscope was used to monitor and record the pulse waveform of discharge. Fig. 4 shows pulse waveform with the constant capacitance of 0.068 μF. It is obvious to find a discharge pulse as the result of breaking down when the gap voltage drops \( V_0 \) instantaneously. By comparison of the pulse waveform in different working fluids, the voltage drops \( V_0 \), peak current \( I_p \) and time duration \( T_e \) were almost the same. This pointed out the pulse waveform, the voltage drop and peak current are basically not affected by ER fluid.

### 3.1.2. Discharge frequency

Discharge spark appears when electric voltage drops instantaneously and electric current increases suddenly. The number of discharge pulse can be viewed through monitor. Fig. 5 shows the number of discharge pulse \( N_e \) during the period of 20 ms (10^{-3} s) for various working fluids. The discharge pulse number is maxima when using general EDM oil. Pure silicon oil is in the second place and \( N_e \) decreased gradually with the increase of starch concentration. ER fluid will become very sticky and the probability of discharging is reduced when the starch concentration is higher. Besides, the discharging spark would appear

![Fig. 7 – The \( R_a \) values of different concentration of ER fluid.](image)

![Fig. 8 – The machined surface for different concentrations of starch and abrasive \( \text{Al}_2\text{O}_3 \) under the discharge capacitance of 0.068 μF and 0.01 μF: (a) 10 wt.% starch without \( \text{Al}_2\text{O}_3 \) \( R_a = 1.24 \mu m \) C = 0.068 μF; (b) 10 wt% starch–10 wt.% \( \text{Al}_2\text{O}_3 \) \( R_a = 0.26 \mu m \) C = 0.068 μF; (c) 20 wt.% starch without \( \text{Al}_2\text{O}_3 \) \( R_a = 1.12 \mu m \) C = 0.068 μF; (d) 20 wt.% starch–10 wt.% \( \text{Al}_2\text{O}_3 \) \( R_a = 0.14 \mu m \) C = 0.068 μF; (e) 10 wt.% starch without \( \text{Al}_2\text{O}_3 \) \( R_a = 0.52 \mu m \) C = 0.01 μF; (f) 10 wt.% starch–10 wt.% \( \text{Al}_2\text{O}_3 \) \( R_a = 0.06 \mu m \) C = 0.01 μF; (g) 20 wt.% starch without \( \text{Al}_2\text{O}_3 \) \( R_a = 0.46 \mu m \) C = 0.01 μF; (h) 20 wt% starch–10 wt.% \( \text{Al}_2\text{O}_3 \) \( R_a = 0.08 \mu m \) C = 0.01 μF.](image)
hardly when using higher concentration of alumina powder in ER fluid. This result leaded to less EDM but more polishing would be carried out with adding Al₂O₃ abrasive.

3.2 Polishing effect

3.2.1 Surface roughness of EDM in ER fluid

Fig. 6 shows the machined surface of EDM when using conventional EDM oil and pure silicon oil under the discharge capacitance of 0.068 μF. The discharge craters were still found apparently and the roughness of pure silicone oil was worse than the one of EDM oil. Fig. 7 shows the investigation results of surface roughness (Rₐ) for different starch concentrations from 10% to 30% when the discharge capacitance of 0.01 μF and 0.68 μF. As the figure indicates, starch concentration has not strong influence on surface roughness of EDM in comparison with the discharge capacitance. In other words, the discharge capacitance is the decisive factor of surface roughness, which determines the energy of discharge pulse.

3.2.2 Surface roughness of EDM in ER fluid with adding Al₂O₃ powders

In this section, the abrasive powder was added in ER fluid composed by starch and polishing effect was investigated. Fig. 8 shows the machined surface using ER fluid and the abrasive Al₂O₃ under the discharge capacitance of 0.068 μF and 0.01 μF. In the result, using ER fluid by adding the Al₂O₃ abrasive of 0.3 μm, there was no crater found and submicron Rₐ obtained. The roughness under the discharge capacitance of 0.068 μF was improved from Rₐ 1.24 μm to Rₐ 0.26 μm for 10% starch concentration, and from Rₐ 1.12 μm to Rₐ 0.14 μm for 20% starch concentration. Mirror-like surface can be obtained when using the smaller capacitance of 0.01 μF. The roughness under the discharge capacitance of 0.01 μF was improved to Rₐ 0.06 μm and Rₐ 0.08 μm after adding Al₂O₃ abrasives of 0.3 μm in the ER fluid of 10% and 20% starch concentration. It is clear that polishing process is surely performed to obtain the surface roughness of nanometer order.

4 Conclusion

In this study, we used the ER fluid and alumina powders to develop the new electromechanical technology combining EDM and polishing. The starch particles gather and become the fibrous chains due to polarization when the electrical field was applied in the ER fluid. Then the fibrous chains provide polishing brushes dragging abrasive powders to carry out polishing. The main results are summarized as follows:

1. The results demonstrate EDM process still can be performed in the ER fluid. The waveform of single discharging pulse is almost the same whenever starch concentration was. However discharge frequency, the pulse number during the constant period decreased with increasing the concentration of starch and alumina. Using more starch particles and alumina powders would reduce discharge efficiency but make longer polishing process time.

2. Only using ER fluid of starch particles without abrasive Al₂O₃ as working fluid, the roughness would be improved a little. In that case, the discharge capacitance is the decisive factor of surface roughness, which determines the energy of discharge pulse.

3. Adding the abrasive in the ER fluid surely has the polishing effect to improve the surface roughness. The roughness by using the ER fluid with alumina powder of 0.3 μm was improved to Rₐ 0.06 μm for discharge capacitance of 0.01 μF, and no crater was found.

REFERENCES


